

4 200 G	N THE I	UNITED STATES PATENT AND	TRADEMARK OFFICE
ARX OF COLUMN	:	Satoh et al.) Group Art Unit 1763
Appl. No.	:	09/764,523) I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class
Filed	:	January 18, 2001	mail in an envelope addressed to: United States Patent and Trademark Office, P.O. Box 2327, Arlington, VA 22202, on
For	:	A SEMICONDUCTOR PROCESSING DEVICE PROVIDED WITH A REMOTE PLASMA SOURCE FOR SELF-CLEANING	March 10, 2003 (Date) Adeel S. Akhtar, Reg. No. 41,394 (Date) Adeel S. Akhtar, Reg. No. 41,394
Examiner	:	Rudy Zervigon	$\begin{array}{c} \left.\begin{array}{c} \left. \\ \end{array}\right. & \\ \end{array}\right. & \\ \end{array}\right. \end{array}\right) \end{array}\right.} \end{array}\right.} \end{array}\right.} \right. \\ \begin{array}{c} \text{REQUIREMENT} \end{array}$
	<u>]</u>	RESPONSE TO RESTRICTION R	REQUIREMENT 7700

RESPONSE TO RESTRICTION REQUIREMENT AND PRELIMINARY AMENDMENT

United States Patent and Trademark Office P.O. Box 2327 Arlington, VA 22202

Dear Sir:

RESPONSE TO RESTRICTION REQUIREMENT

In an action mailed February 11, 2003, the Examiner required restriction of prosecution to one of the following groups of claims:

Group I Claims 1-32, drawn to a chemical vapor deposition device; and

Group II Claims 33-44, drawn to a method of cleaning a chemical vapor deposition device..

In response, Applicants elect, without traverse, to proceed with examination on the merits of Group II (Claims 33-44).

Appl. No.

: 0. 4,5

Filed

January 18, 2001

Applicants note for the record that Claims 41-44 are actually apparatus claims, and not method claims contrary to the Examiner's restriction requirement. If further restriction is required, the Examiner is respectfully requested to call the undersigned to expedite prosecution.





Case Docket No. ASMJP.055AUS

Date: March 10, 2003

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n re application of:

Satoh et al.

App. No.

09/764,523

Filed

January 18, 2001

For

A SEMICONDUCTOR

PROCESSING DEVICE PROVIDED WITH A

REMOTE PLASMA SOURCE

FOR SELF-CLEANING

Examiner

Rudy Zervigon

Art Unit

1763

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> March 10, 2003 (Date)

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Arlington, VA 22202

Sir:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated as shown below:

CLAIMS AS FILED								
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE		
Total Claims	13		44	= 0 ×	\$18	= \$0		
Independent Claims	2	_	4	= 0 ×	\$84	= \$0		
If application has bee dependent claim(s),	2		\$280	= \$0				
Time Extension Fee	<u> </u>			\$0				
				TOTAL ADD FOR THIS A	E \$0			

(X) Return prepaid postcard.



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Date: March 10, 2003

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- (X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.
- (X) Please use Customer No. 20,995 for the correspondence address.

Adeel S. Akhtar Registration No. 41,394 Attorney of Record Customer No. 20,995

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